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PTO-1449/A and B (Modified)  
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FORM PTO-1449/A and B (Modified)				APPLICATION NO.:	ATTY. DOCKET NO.: V004442-WRM
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				FILING DATE: November 20, 2001	CONFIRMATION NO.: 882
				APPLICANT: John H. Keller, et al.	
Sheet	1	of	1	GROUP ART UNIT: 2821	EXAMINER: Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner's Initials	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document CLASS / SUBCLASS	Date of Publication or of issue of Cited Document MM-DD-YYYY
		Number	Kind Code		
TV		5,969,366		England et al 250/492,21	10-19-1999
TV		5,748,360		Chikyou et al 359/298	05-05-1998

FOREIGN PATENT DOCUMENTS

Examiner's Initials	Cite No.	Foreign Patent Document			Name of Patentee or Applicant of Cited Document (not necessary)	Date of Publication of Cited Document MM-DD-YYYY	Translation (Y/N)
		Office/ Country	Number	Kind Code			
		EP	0 829 899		Patent Abstracts of Japan	03-18-1998	
		Japan	01 209645		Advanced Lithography Group	08-23-1989	

OTHER ART — NON PATENT LITERATURE DOCUMENTS

Examiner's Initials	Cite No	Include name of the author (in CAPITAL LETTERS) title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, relevant page(s), volume-issue number(s), publisher, city and/or country where published.	Translation (Y/N)

EXAMINER

TUYET VO

DATE CONSIDERED

4/22/03

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\*a copy of this reference is not provided as it was previously cited by or submitted to the office in a prior application, Serial No. \_\_\_, filed \_\_\_, and relied upon for an earlier filing date under 35 U.S.C. 120 (continuation, continuation-in-part, and divisional applications).

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FORM PTO-1449/A and B (Modified)				APPLICATION NO.: 09/988,565	ATTY. DOCKET NO.: V0077/7215
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>				FILING DATE: November 20, 2001	
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				GROUP ART UNIT: 2821	
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		Number	Kind Code		
✓	1	*6,326,631	B1	Politiuk et al	250/1492.21 12-04-2001
✓	2	*6,040,582		Kim	250/1492.21 03-21-2000
✓	3	*5,932,882		England et al	250/1492.21 08-03-1999
	4	*5,969,366		England et al	250/1492.21 10-19-1999
	5	*5,729,028		Rose	250/1492.21 03-17-1998
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	8	*5,387,843		Nagayama et al	315/111.81 02-07-1995
	9	*5,196,706		Keller et al	250/396R 03-23-1993
✓	10	*4,146,810		Hicks et al	313/11 03-27-1979

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✓	11	*H. Ito et al, "Low Energy Beam Extraction in Terms of Magnetic Field, Electric Field and Ion Optics", IEEE, 1997, pages 383-386	

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TUYET VO	4/22/03

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